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CONFIRMATION NO. 4772

<b>SERIAL NUMBER</b> 10/691,108	<b>FILING OR 371(c) DATE</b> 10/22/2003 <b>RULE</b>	<b>CLASS</b> 216	<b>GROUP ART UNIT</b> 1765	<b>ATTORNEY DOCKET NO.</b> 10191/3399
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## APPLICANTS

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\*\* CONTINUING DATA \*\*\*\*\* *NONE W*\*\* FOREIGN APPLICATIONS \*\*\*\*\* *YES LV*

GERMANY 102 49350.2 10/23/2002

IF REQUIRED, FOREIGN FILING LICENSE GRANTED \*\*

01/22/2004

Foreign Priority claimed <input checked="" type="checkbox"/> yes <input type="checkbox"/> no	STATE OR COUNTRY GERMANY	SHEETS DRAWING 9	TOTAL CLAIMS 5	INDEPENDENT CLAIMS 4
35 USC 119 (a-d) conditions met <input checked="" type="checkbox"/> yes <input type="checkbox"/> no <input type="checkbox"/> Met after Allowance				
Verified and Acknowledged Examiner's Signature <i>[Signature]</i> Initials <i>[Initials]</i>				

## ADDRESS

26646

## TITLE

Device and method for anisotropic plasma etching of a substrate, particularly a silicon element

**FILING FEE  
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986

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